CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): GEUN-YOUNG YEOM

Serial No.
10/086,497

February 28, 2002

Alejandro Mulero, Luz L.

Docket No.
HNE-0003

Filing Date

Examiner

Group Art Unit
1763

Invention: LAYER-BY-LAYER ETCHING APPARATUS USING NEUTRAL BEAM AND ETCHING METHOD

USING THE SAME

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**GROUP 1700** 

I hereby certify that this Response to Restriction Requirement; Limited Recognition Under 37 CFR Section 10.9(b)

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Soonja Bae is hereby given limited recognition under 37 CFR § 10.9(b) as an employee of Cantor Colburn LLP to prepare and prosecute patent applications wherein the patent applicant is the client of Cantor Colburn LLP, and the attorney or agent of record in the applications is a registered practitioner who is a member of Cantor Colburn LLP. This limited recognition shall expire on the date appearing below, or when whichever of the following events first occurs prior to the date appearing below: (i) Soonja Bae ceases to lawfully reside in the United States, (ii) Soonja Bae's employment with Cantor Colburn LLP ceases or is terminated, or (iii) Soonja Bae ceases to remain or reside in the United States on an H-1 visa.

This document constitutes proof of such recognition. The original of this document is on file in the Office of Enrollment and Discipline of the U.S. Patent and Trademark Office.

Expires: August 15, 2003

Harry I. Moatz

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE MAY 1 4 7003

APPLICANT:

**GEUN-YOUNG YEOM** 

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SERIAL NO.:

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FOR:

LAYER-BY-LAYER ETCHING APPARATUS

Alejandro

USING NEUTRAL BEAM AND

Mulero, Luz L.

ETCHING METHOD USING THE SAME

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## RESPONSE TO RESTRICTION REQUIREMENT WITH AMENDMENT, PURSUANT TO 37 C.F.R. §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is a response to an office action dated April 10, 2003, wherein the Examiner has subjected claims 1-21 to a restriction requirement. Consideration of this response and examination on the merits is respectfully requested.